

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Jin Zhao Confirmation No.: 4854  
Application Number : 10/623,757  
Filed : July 21, 2003  
Title : MAINTAINING A REACTOR CHAMBER OF A CHEMICAL  
VAPOR DEPOSITION SYSTEM  
TC/Art Unit : 4151  
Examiner: : Smith, Francis P.  
  
Docket No. : TI-35855 (0025.0220)  
Customer No. : 23494

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed December 26, 2007, please amend the  
above-identified application as follows:

**Amendments to the Claims** begin at page 2 of this paper.

**Remarks/Arguments** begin at page 13 of this paper.